

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Junji KUNISAWA et al. :  
Serial No. NEW : **Attn: APPLICATION BRANCH**  
Filed 1746 : Attorney Docket No. 2003\_1074

HOLDING UNIT, PROCESSING APPARATUS  
AND HOLDING METHOD OF SUBSTRATES  
(Rule 1.53(b) Continuation  
of Serial No. 09/984,791,  
Filed October 31, 2001)

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
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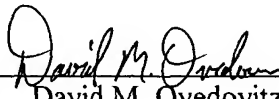
Sir:

Applicants in the above-entitled application hereby claim the dates of priority under the International Convention of Japanese Patent Application No. 332163/2000, filed October 31, 2000, and Japanese Patent Application No. 114947/2001, filed April 13, 2001, as acknowledged in the Declaration of this application.

Certified copies of said Japanese Patent Applications are of record in parent application Serial No. 09/984,791, filed October 31, 2001.

Respectfully submitted,

Junji KUNISAWA et al.

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